

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	155414	(wafer or substrate) near3 (focus\$3 or tilt\$3 or height or position\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/05 16:26
L2	181710	(expos\$5 or project\$3) same (mask or reticle)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/05 16:27
L3	24876	1 and 2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/05 16:27
L4	234972	(expos\$3 near (area or region or portion)) or (shot near area)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/05 16:28
L5	3042	4 with (measur\$5 or detect\$3 or sens\$3 or determin\$5) with (focus\$3 or position\$3 or tilt\$3 or height)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/05 16:31
L6	1070	5 and 3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/05 16:29
L7	251	4 with (measur\$5 or detect\$3 or sens\$3 or determin\$5) with (focus\$3 or position\$3 or tilt\$3 or height) with (proceed\$3 or prior or succeed\$3 or subsequent or outside)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/05 16:30
L8	140	6 and 7	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/05 16:31

L9	1096588	(point or position) near3 (measur\$5 or detect\$3 or sens\$3 or determin\$5)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/05 16:32
L10	138	8 and 9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/05 16:32

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9/5/05